

Electronic Acknowledgement Receipt

EFS ID:	1278065
Application Number:	10768611
International Application Number:	
Confirmation Number:	7083
Title of Invention:	SEMICONDUCTOR DEVICE WITH NITROGEN IN OXIDE FILM ON SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURING THE SAME
First Named Inventor/Applicant Name:	Eiji Hasegawa
Customer Number:	2352
Filer:	Max Moskowitz/Cheryl Godfrey
Filer Authorized By:	Max Moskowitz
Attorney Docket Number:	P/29-1647
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Application Type:	Utility

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Applicant summary of interview with examiner	00795129.pdf	47090	no	2

Warnings:

Information:**Total Files Size (in bytes):**

47090

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.